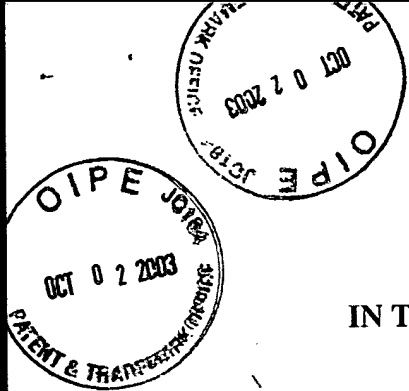


41.

1752-



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED
OCT 07 2003
TC 1700

In re application of
Toshiyuki OGATA, et al.

Docket No: Q65755

Appln. No.: 09/922,723

Group Art Unit: 1752

Confirmation No.: 1261

Examiner: Sin J. Lee

Filed: August 7, 2001

For: **POSITIVE RESIST COMPOSITION AND BASE MATERIAL CARRYING LAYER OF
THE POSITIVE RESIST COMPOSITION**

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 2, 2003, please amend the above-identified application as follows on the accompanying pages.

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